

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hideo SHITE **Confirmation No.: 6783**  
Serial No. : 10/538,727  
Filed : June 13, 2005  
Art Unit : 1792  
Examiner : Yewebdar T. Tadesse  
For : COATING PROCESS APPARATUS AND COATING FILM  
FORMING METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 26, 2008 please amend the above-identified application as set forth below and consider the following arguments.

Amendments to the Claims begin on page 2.

Remarks begin on page 6.